

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date December 6, 2002

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. Zervigon

Filed: September 27, 200

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

#18  
12/9/02  
MW**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

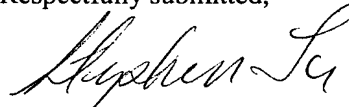
Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 6, 2002, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 136963 in the amount of \$110 in payment for:

  X   Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
       Extension fee for response within second month pursuant to §1.136(a) (\$400.00)  
       Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075Stephen Tu  
Registration No. 52,304

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JAO:SXT/amw

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DEPOSIT ACCOUNT USE  
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